

**Search Notes**

Application/Control No.

10/554,263

Examiner

David E. Bochna

Applicant(s)/Patent under  
Reexamination

KIM, SUKYOON

Art Unit

3679

**SEARCHED**

| Class | Subclass | Date | Examiner |
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**INTERFERENCE SEARCHED**

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**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

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| Updated the previous search | 7/2/2007 | DB   |
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